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Atty. Docket No: MTRL020US0

MAR 22 2005

Customer ID No. 37141

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Balgovind K. Sharma
Serial No.: 10/618,228
Filing Date: July 11, 2003
Examiner: Tran, Binh X.
Art Unit: 1765
Title: MICELLAR TECHNOLOGY FOR POST-ETCH RESIDUES

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Certification Under 37 C.F.R. 1.8Date of Mailing: March 22, 2005

I hereby certify that I have caused the documents indicated herein to be facsimile transmitted to the U.S. Patent Office under 37 CFR § 1.8 on the date indicated above.

Reina R. Bernfeld
Reina R. Bernfeld

**INFORMATION DISCLOSURE
STATEMENT UNDER 37 CFR § 1.97(c)(2)**

Dear Sir:

Applicants respectfully request, pursuant to 37 C.F.R. §§ 1.97 and 1.98, that the art listed on the attached PTO-1449 form be considered and cited in the examination of the above-identified application.

Citation of the documents shall not be construed as:

- 1) an admission that the documents are necessarily prior art with respect to the instant invention;
- 2) a representation that a search has been made, other than as described above; or
- 3) an admission that the information cited herein is, or is considered to be, material to patentability as defined in § 1.56(b).

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Applicants enclose herewith the fee according to 37 CFR § 1.17(p), however, if any further fees or credits are due, the Commissioner is hereby authorized to charge or credit Fortkort Grether + Kelton LLP, Deposit Account No. 50-2726.

Should the Examiner have any questions or desire clarification of any sort, the Examiner is invited to telephone the undersigned at the number listed below. Please reference Attorney Docket No. MTRL020US0.

Respectfully submitted,

FORTKORT GRETHER + KELTON LLP

Date: 3-22-2005By: John A. Fortkort
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INFORMATION DISCLOSURE STATEMENT BY APPLICANT				COMPLETE IF KNOWN	
				Application Number	10/618,228
				Filing Date	July 11, 2003
				First Named Inventor	Sharma, B.
				Group Art Unit	1765
				Examiner Name	Tran, Binh X.
Sheet	1	Of	1	Attorney Docket Number	MTRL020US0

U.S. PATENT DOCUMENTS						
Examiner Initials	Cite No.	Document Number	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document mm-dd-yy	Class	Subclass

Foreign Patent Documents									
Examiner Initials	Cite No.	Foreign Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document	Class	Subclass	Translation	
		Office	Number						

Non Patent Literature Documents		
Examiner Initials*	Cite No.	
		International Sematech, "Low-K Dielectrics"; 2001 Annual Report; 2 pages

Examiner Signature		Date Considered	
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